

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
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Shinji MAEKAWA et al.)
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Serial No.: 10/827,457)
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Filed: April 19, 2004)
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For: Method For Forming Pattern And)
 Drop Discharge Apparatus)
)
Examiner: Marianne L. Padgett)
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Art Unit: 1792)
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Confirmation No.: 2984)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT F (AFTER FINAL)

Applicants have the following response to the Final Rejection of July 23, 2008, a RCE being filed herewith.

Please amend the above-identified application as follows: